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Asst. Commissioner for Patents  
Washington, DC 20231

OFGS File No. : P/1250-214  
Inventor : Masayoshi SHIGA et al  
Title : SUBSTRATE PROCESSING APPARATUS, SUBSTRATE  
INSPECTION METHOD AND SUBSTRATE PROCESSING SYSTEM  
Assignee : Dainippon Screen Mfg. Co., Ltd.

Enclosed herewith please find the following documents in the above-identified application for United States Letters Patent:

09942153-033901

☒ Print EFS Data Sheet  
☒ 35 Pages of Specification including Abstract and Claims  
☒ 19 Numbered Claims Calculated as 19 Claims for Fee Purposes  
☒ 8 Sheets of Drawing Containing Figures 1 to 8. (Formal)  
☒ Declaration and Power of Attorney  
☒ Priority is Claimed under 35 U.S.C. §119:  
Convention Date September 1, 2000 for Japan Appln. S.N. 2000-265318  
Convention Date July 10, 2001 for Japan Appln. S.N. 2001-209088  
☐ Certified Priority Application  
☐ Small Entity Status is claimed.  
☒ Assignment  
☒ Return-Addressed Post Card

OFGS Check No. 6237, which includes the fee of \$910.00, calculated as follows:  
Basic Filing Fee: . . . . . \$ 710.00  
Additional Filing Fees:  
Total Number of Claims in Excess of 20, times \$18: . . . . .  
Number of Independent Claims in Excess of 3, times \$80: . . . . . 160.00  
One or More Multiple Dependent Claims: Total \$270. . . . .  
Total Filing Fees or . . . . . 870.00  
Total Filing Fee Reduced 50% for Small Entity: . . . . .  
Assignment Recording Fee: \$40 . . . . . 40.00  
TOTAL Filing Fee and Assignment Recording Fee: . . . . . \$ 910.00

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EXPRESS MAIL CERTIFICATE

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail Post Office to Addressee (mail label #EL918242364US) in an envelope addressed to: Asst. Commissioner for Patents, Washington, D.C. 20231, on August 29, 2001:

Dorothy Jenkins

Name of Person Mailing Correspondence

*Dorothy Jenkins*

Signature  
August 29, 2001

Date of Signature

Respectfully submitted,

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APPLICATION INFORMATION

Title Line One:: SUBSTRATE PROCESSING APPARATUS, SUBSTRAT  
Title Line Two:: E INSPECTION METHOD AND SUBSTRATE PROCES  
Title Line Three:: SING SYSTEM  
Total Drawing Sheets:: 8  
Formal Drawings?: Yes  
Application Type:: Utility  
Docket Number:: P/1250-214  
Secrecy Order in Parent Appl.?: No

PRIOR FOREIGN APPLICATIONS

000002352

**THE UNIVERSITY OF CHICAGO**